



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Katsunori SUZUKI et al.

Group Art Unit: 1763

Application No.: 10/790,188

Examiner: S. MACARTHUR

Filed: March 2, 2004

Docket No.: 118655

For: QUARTZ COMPONENT FOR PLASMA PROCESSING APPARATUS AND  
RESTORING METHOD THEREOF

**APPLICANTS' SUMMARY OF SUBSTANCE OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Sir:

Applicants' representative, Obert Chu, conducted an interview in connection with the above-referenced matter with Examiner MacArthur at the United States Patent and Trademark Office on February 21, 2007. Applicants thank Examiner MacArthur for the courtesies extended to the representative.

In the interview, Applicants' representative explained that the claimed invention contains a second region having a height lower than that of the first region extending outwardly from the outer perimeter of the first portion to the outer perimeter of the quartz ring. Examiner MacArthur agreed that the claimed invention appears to be patentably distinct over the applied prior art (U.S. Patent Publication No. 2003/0029565 to Suzuki et al. (Suzuki), U.S. Patent No. 6,391,787 to Dhindsa et al. (Dhindsa) and U.S. Patent Publication No. 2002/0139478 Ma et al. (Ma)). Examiner MacArthur further indicated that she would conduct a further search of the prior art as part of the examination of this application, and to

issue a Notice of Allowance if she fails to discover art that is more relevant than the art currently of record.

Respectfully submitted,



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JAO:OHC/mdw

Date: March 6, 2007

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